

[USPTO PATENT FULL-TEXT AND IMAGE DATABASE](#)[Home](#)[Quick](#)[Advanced](#)[Pat Num](#)[Help](#)[Next List](#)[Bottom](#)[View Cart](#)*Searching US Patent Collection...***Results of Search in US Patent Collection db for:**

AN/"Chroma ATE Inc": 95 patents.

Hits 1 through 50 out of 95[Final 45 Hits](#)[Jump To](#)[Refine Search](#)

PAT. NO.	Title
1 11,269,170	Separate microscopy system and adjusting method thereof
2 11,209,371	Optical detecting device and calibrating method
3 11,169,178	Locking mechanism for a press head and electronic device testing apparatus comprising the same
4 11,156,669	Battery testing device and method thereof
5 11,143,640	Rotating buffer station for a chip
6 11,080,860	Image inspection method
7 11,073,852	Electronic load apparatus
8 11,061,067	Apparatus and method for a high temperature test and a low temperature test and configured to maintain an electronic component under test near a test temperature
9 10,989,660	Automatic fluorescence detection system
10 10,965,096	Fixture assembly for testing surface emitting laser diodes and testing apparatus having the same
11 10,948,518	Test apparatus for testing electronic device
12 10,910,627	Battery formation system and probe supporting structure thereof
13 10,903,618	Fixture assembly for testing edge-emitting laser diodes and testing apparatus having the same
14 10,890,624	Testing fixture, testing system for cell temperature probe and method for testing cell temperature probe
15 10,879,097	Modular pressing device capable of generating stage downward forces and electronic device testing apparatus comprising the same
16 10,845,386	Probe pin alignment apparatus
17 10,825,588	Voltage dividing resistor
18 10,811,720	Battery cell tray
19 10,802,070	Testing device and testing method with spike protection
20 10,718,635	Contact detection circuit of four-terminal measurement device
21 10,712,366	Electrical probe
22 10,673,104	Method for testing semi-finished battery cell

- 23 [10,670,627](#)  [Electrical probe structure](#)
- 24 [10,665,906](#)  [Battery cell formation device and probe supporting structure thereof](#)
- 25 [10,527,671](#)  [Absorption testing apparatus](#)
- 26 [10,520,528](#)  [Dew resistant module for test socket and electronic component testing device having the same](#)
- 27 [10,508,969](#)  [Method and device for testing air tightness](#)
- 28 [10,488,459](#)  [Device for pressing electronic component with different downward forces](#)
- 29 [10,481,209](#)  [Method for checking a wire connection](#)
- 30 [10,436,636](#)  [Optical measuring device](#)
- 31 [10,436,580](#)  [Surface measurement system](#)
- 32 [10,411,646](#)  [Inspection method and inspection system of solar cell](#)
- 33 [10,309,986](#)  [Temperature-controlled module for electronic devices and testing apparatus provided with the same](#)
- 34 [10,291,116](#)  [Output control method for a digital controller of a source measure unit](#)
- 35 [10,254,310](#)  [Electrical probe with a probe head and contacting pins](#)
- 36 [10,254,308](#)  [Electronic device testing apparatus with locking mechanism for pressing header and socket plate](#)
- 37 [10,215,812](#)  [Clamp-type probe device](#)
- 38 [10,034,410](#)  [Support apparatus](#)
- 39 [9,983,259](#)  [Dual loop type temperature control module and electronic device testing apparatus provided with the same](#)
- 40 [9,954,255](#)  [Measurement fixture for a battery cell](#)
- 41 [9,841,737](#)  [Automatic test system and method](#)
- 42 [9,841,487](#)  [Calibration board for calibrating signal delays of test channels in an automatic test equipment and timing calibration method thereof](#)
- 43 [9,823,295](#)  [Battery simulator](#)
- 44 [9,706,098](#)  [Inspection system and method for obtaining an adjusted light intensity image](#)
- 45 [9,678,158](#)  [Apparatus for testing a package-on-package semiconductor device](#)
- 46 [9,658,283](#)  [Radiator module system for automatic test equipment](#)
- 47 [9,647,650](#)  [Clock generating device](#)
- 48 [9,638,740](#)  [Test system with rotational test arms for testing semiconductor components](#)
- 49 [9,568,245](#)  [Heating furnace](#)
- 50 [9,519,024](#)  [Apparatus for testing package-on-package semiconductor device and method for testing the same](#)

